Amendment of the Claims

The following list of claims replaces all previous version(s) of claims.

1. (Currently Amended) A trench-type storage device comprising:

a substrate;

at least one trench in said substrate;

conductive carbon nanotubes lining said trench; and

a trench conductor filling said trench,

wherein said trench conductor and said substrate having a co-planar top surface.

2. (Currently Amended) The storage device in claim 1, A trench-type storage device comprising:

a substrate;

at least one trench in said substrate;

conductive carbon nanotubes lining said trench;

a trench conductor filling said trench; and

further comprising—a trench dielectric between said carbon nanotubes and sidewalls of said trench.

- 3. (Currently Amended) The storage device in claim 1, <u>further comprising a layer of trench dielectric on top of a bottom of said trench and between said carbon nanotubes and sidewalls of said trench, wherein characterized in that the conductive carbon nanotubes form an open cylinder structure lining <u>said sidewalls of said trench through said layer of trench dielectric.</u></u>
- 4. (Currently Amended) The storage device in claim 1, wherein characterized in that the trench conductor comprises at least one of polysilicon, a metal, and an alloy thereof, contacting said layer of trench dielectric on top of said bottom of said trench.

- 5. (Currently Amended) The storage device in claim 1, characterized in that the conductive carbon nanotubes and a separate the trench conductor material are disposed in the trench, and the trench conductor material is carbon free.
- 6. (Original) The storage device in claim 1, characterized in that the substrate is free of carbon nanotube catalyst materials.
- 7. (Original) The storage device in claim 1, characterized in that the carbon nanotubes form a consistent lining along approximately the entire length of sidewalls of said trench.
- 8. (Currently Amended) The storage device in claim 2[[1]], characterized in that the trench-type storage device is planarized so that a top surface of the substrate is coplanar with respective top surfaces of the trench dielectric, the conductive carbon nanotubes nanotube and the trench conductor.
- 9. (Original) The storage device in claim 1, characterized in that the conductive carbon nanotubes are grown downwards into the trench.
- 10. (New) The storage device in claim 1, further comprising a trench dielectric between said carbon nanotubes and sidewalls of said trench.

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